

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Fumiyoshi ONO

Divisional of Appln. No. 09/313,356

Group Art Unit: Not yet assigned

Filed: September 29, 2000

Examiner: Not yet assigned

For: COMPOSITION FOR POLISHING METAL ON SEMICONDUCTOR WAFER AND  
METHOD OF USING SAME



INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §§ 1.97 and 1.98

Assistant Commissioner for Patents  
Washington, D.C. 20231

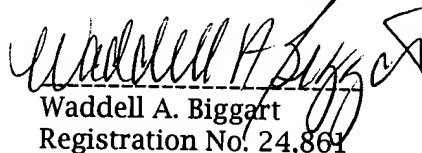
Sir:

In accordance with the duty of disclosure under 37 CFR §1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO-1449 form which are all the references of record in parent application No. 09/313,356. Applicant is not submitting duplicate copies of these references but requests that they be listed on the face of any patent granted on the above application. (See 1138 TMOG 39, second column, last paragraph, last sentence.)

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

**BEST AVAILABLE COPY**

Respectfully submitted,

  
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